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Davari, Pooya; Xue, Peng

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Comparative Study on Temperature Dependency of dV/dt , dI/dt and EMI Generation for IGBTs, Si and SiC MOSFETs

Peng Xue ^{#1}, Pooya Davari, ^{#2},

[#]Department of Energy, Aalborg University, Aalborg East 9220, Denmark

¹pexu@energy.aau.dk, ²pda@energy.aau.dk

Abstract—In this paper, a study on the temperature dependency of the dV/dt and dI/dt and electromagnetic interference (EMI) generation is proposed for IGBT, Si MOSFET and SiC MOSFET. During the switching transient, the junction temperature T_{J1} of the low-side switch affects the switching behavior, while the junction temperature T_{J2} of the high-side switch affects turn-on characteristics. The impacts of T_{J1} and T_{J2} are thereby investigated separately to identify their influence on the dV/dt , dI/dt and EMI generation. Based on theoretical analyses and experimental study, the dependencies of the T_{J1} and T_{J2} on dV/dt and dI/dt for IGBT, Si MOSFET and SiC MOSFET are clarified. Using the fast Fourier transform (FFT) on the trapezoidal switching waveforms of the devices, the dependencies of T_{J1} and T_{J2} on the EMI generation are also investigated.

Keywords—temperature dependent, dI/dt , dV/dt , EMI, SiC MOSFET, IGBT, Si MOSFET

I. INTRODUCTION

Nowadays, the temperature dependency of dV/dt , dI/dt and EMI generation of power devices has drawn considerable attention from industry and academia [1], [2], [3], [4], [5]. In [1], [2], [6], the temperature-dependent dV/dt and dI/dt of Si insulated gate bipolar transistor (IGBTs) is studied. Due to the booming of silicon carbide (SiC) MOSFET technology, the temperature dependency of dV/dt and dI/dt and EMI generation for SiC MOSFETs are also investigated in a few papers [4], [5], [7].

The previous studies [1], [2], [3], [4] have some limitations. Firstly, the research mainly focuses on the junction temperature T_{J1} of the low-side active switch. During the switching transient, the junction temperature T_{J2} of the high-side switch can also have a significant impact on the reverse recovery characteristics of its freewheeling diode, which affects the turn-on behavior. The impact of T_{J1} and T_{J2} are thereby needed to be studied separately to identify their temperature dependency on dV/dt and dI/dt . Secondly, the studies mainly focus on a few specific kind of devices. A comparison study on the temperature-dependency of dV/dt and dI/dt for the mainstream power devices like IGBTs, Si and SiC MOSFETs are thereby needed. Last but not least, due to the temperature-dependent dV/dt and dI/dt , the EMI generation also depends on T_{J1} and T_{J2} . However, the related studies receive scarcely attention. The temperature-dependency of EMI generation thereby requires further investigation.

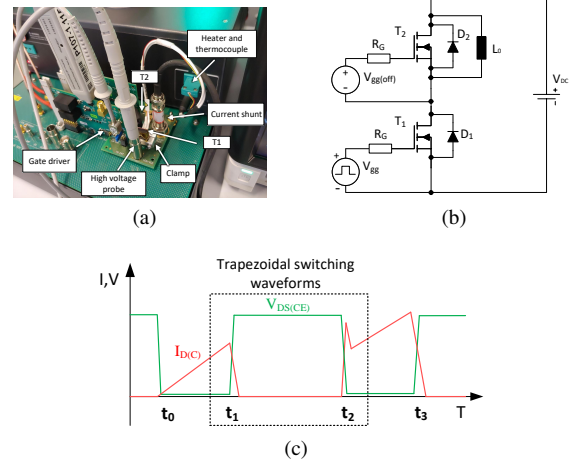


Fig. 1. (a) Double-pulse test fixture. (b) Double-pulse test circuit. (c) Trapezoidal switching waveform obtained from double-pulse test.

In this paper, the temperature dependencies on the dV/dt , dI/dt and EMI generation for the IGBTs I_1 and I_2 , Si MOSFETs M_1 and SiC MOSFETs S_1 , S_2 and S_3 are extensively investigated using the double-pulse test shown in Fig. 1. The Si MOSFETs M_1 is IXFH60N65X2. The IGBTs I_1 and I_2 are IKW40N65ET7 and IKW40N120C. The SiC MOSFETs S_1 , S_2 and S_3 are C3M0045065D, TW048N65C and C2M0080120D. The impact of junction temperature T_{J1} for low-side switch T_1 and junction temperature T_{J2} for high-side switch T_2 on dV/dt , dI/dt are investigated separately. The temperature-dependent parameters and the impact on the dV/dt and dI/dt are investigated theoretically and experimentally for the devices to reveal their T_{J1} and T_{J2} dependencies. The T_{J1} and T_{J2} dependent EMI germination are studied using fast Fourier transform (FFT) on the trapezoidal switching waveforms.

II. ANALYSIS ON TEMPERATURE DEPENDENCY OF dI/dt AND dV/dt OF IGBTs, Si AND SiC MOSFETs

A. T_{J1} dependency of Turn-on dI/dt

The temperature dependency of turn-on $dI/dt|_{on}$ is [8]:

$$\left. \frac{dI^2}{dt dT} \right|_{on} = \frac{\alpha_1 \frac{dG_m}{dT} + \beta_1 \frac{dV_{th}}{dT}}{\tau_a^2} \quad (1)$$

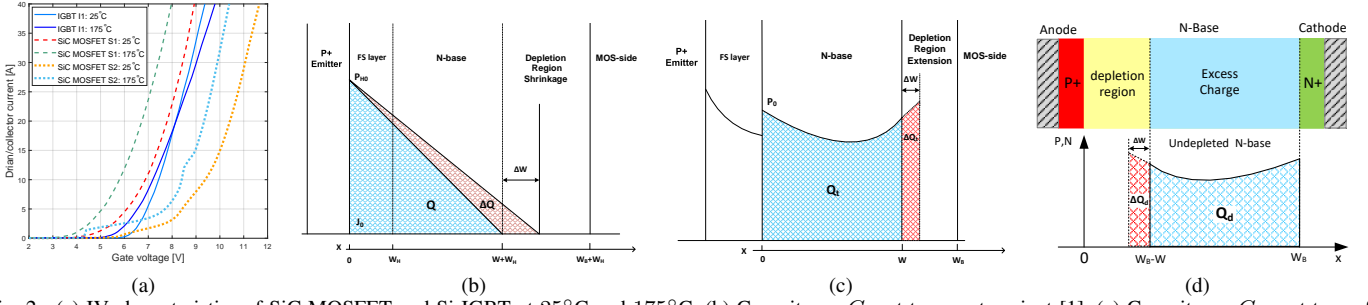


Fig. 2. (a) IV characteristics of SiC MOSFET and Si IGBT at 25°C and 175°C. (b) Capacitance C_Q at turn-on transient [1]. (c) Capacitance C_{ext} at turn-on transient [2]. (d) Charge extraction capacitance $C_{ext,d}$ of bipolar power diode.

where $\alpha_1 = R_G(C_{GS} + C_{GD})(V_{GG(on)} - V_{th})$ and $\beta_1 = -G_m\tau_a$. α_1 is positive while β_1 is negative. As shown in Fig. 2a, SiC MOSFETs have a negative temperature coefficient (NTC) for V_{th} . Its G_m can have a positive temperature coefficient (PTC). The impacts of dV_{th}/dT and dG_m/dT thereby add up, which induces a PTC for the $dI/dt|_{on}$ of SiC MOSFET.

The G_m and V_{th} of IGBTs and Si MOSFETs have NTCs, as shown in Fig. 2a. The impact of dV_{th}/dT and dG_m/dT on $dI^2/dt|_{on}$ thereby counteracts. The temperature dependencies on $dI/dt|_{on}$ for the devices are thereby much weaker than that of the SiC MOSFET. Since G_m usually has much stronger temperature dependency, NTCs of $dI/dt|_{on}$ are obtained for IGBTs, Si and SiC MOSFETs.

B. T_{J1} dependency of Turn-off dI/dt

The temperature dependency of turn-off $dI/dt|_{off}$ of IGBT, Si and SiC MOSFETs is [8]:

$$\left. \frac{dI^2}{dt} \right|_{off} = \frac{\alpha_2 \frac{dG_m}{dT} + \beta_2 \frac{dV_{th}}{dT}}{\tau_a^2} \quad (2)$$

Where $\alpha_2 = R_G(C_{GS} + C_{GD})(V_{th} - V_{GG(off)}) - L_S I_L$ and $\beta_2 = G_m\tau_a$. Noting that β_2 is much larger than α_2 in typical applications, the $dI^2/dt|_{off}$ is thereby mainly determined by dV_{th}/dT . Since the IGBT, Si MOSFET and SiC MOSFET have NTCs for V_{th} , their $dI/dt|_{off}$ thereby has a NTC.

C. T_{J1} dependency of Turn-on dV/dt

1) IGBT: Temperature dependency of turn-on dV_{CE}/dt of IGBT is [1]:

$$\left. \frac{dV_{CE}^2}{dt} \right|_{on} = \frac{\alpha_3 \frac{dG_m}{dT} + \beta_3 \frac{dV_{th}}{dT} + \zeta_3 \frac{dC_Q}{dT}}{\tau_b^2} \quad (3)$$

$\beta_3 = -G_m\tau_b$. $\zeta_3 = -(G_m(V_{GG(on)} - V_{th}) - I_L)$. $\alpha_3 = (C_Q + C_{CE} + C_{OSS2} + C_{GC})(V_{GG(on)} - V_{th}) + I_L R_G C_{GC}$. $\tau_b = C_Q + C_{CE} + C_{OSS2} + C_{GC}(1 + G_m R_G)$. I_L is the load current. C_{OSS2} is the equivalent capacitance of high-side MOSFET. When the depletion region reduces, the excess charge Q increases as shown in Fig. 2b. C_Q is the capacitance generated by the dynamics of N-base excess charge[1].

In the beginning of voltage falling transient, C_Q is approximately temperature independent because high-level injection is not achieved in the N-base [1], which induces a relatively weak temperature dependency on $dV_{CE}/dt|_{on}$.

At the end of the turn-on transient when high-level injection conditions is achieved, C_Q is strongly temperature-dependent. This induces the NTC for $dV_{CE}/dt|_{on}$ since ζ_3 is negative.

2) Unipolar devices: Temperature dependency of turn-on dV_{ds}/dt of Si and SiC MOSFETs is:

$$\left. \frac{dV_{DS}^2}{dt} \right|_{on} = \frac{\alpha_4 \frac{dG_m}{dT} + \beta_4 \frac{dV_{th}}{dT}}{\tau_c^2} \quad (4)$$

Where $\alpha_4 = (C_{DS} + C_{OSS2} + C_{GD})(V_{GG(on)} - V_{th}) + I_L R_G C_{GD}$. $\beta_4 = -\tau_c G_m$. In (4), α_4 is positive whereas the ζ_4 is negative. For Si MOSFET, their G_m and V_{th} have NTCs. The impacts of dG_m/dT and dV_{th}/dT thereby counteract, which induces relatively weak temperature dependency of $dV_{DS}/dt|_{on}$. For SiC MOSFET, its G_m has a PTC and V_{th} has an NTC. The impacts of dG_m/dT and dV_{th}/dT add up, which induce a relatively large PTC for $dV_{DS}/dt|_{on}$. A strong temperature dependency on $dV_{DS}/dt|_{on}$ is thereby achieved for SiC MOSFET.

D. T_{J1} dependency of Turn-off dV/dt

1) IGBT: Temperature dependency of turn-off dV_{CE}/dt is:

$$\left. \frac{dV_{CE}^2}{dt} \right|_{off} = \frac{\alpha_5 \frac{dG_m}{dT} + \beta_5 \frac{dV_{th}}{dT} + \zeta_5 \frac{dC_{ext}}{dT}}{\tau_d^2} \quad (5)$$

Where $\tau_d = C_{ext} + C_{CE} + C_{GC}(1 + G_m R_G)$. $\alpha_5 = (C_{ext} + C_{CE} + C_{GC})(V_{th} - V_{GG(off)}) - C_{GC} R_G b I_L / (1 + b)$. $\beta_5 = G_m\tau_d$. $\zeta_5 = -(G_m(V_{th} - V_{GG(off)}) + b I_L / (1 + b))$. As shown in Fig. 2c, when the depletion region extends, the excess charge Q_t is extracted in the N-base, which generates a capacitive current. The equivalent capacitance C_{ext} is used to represent the capacitive behaviour [2], [9].

Compare to the V_{th} and G_m , the temperature dependency of C_{ext} is much stronger and thereby dominate the $dV_{CE}^2/dt|_{off}$ [2], [6]. Since C_{ext} has a PTC, a NTC is obtained for $dV_{CE}/dt|_{off}$ due to the negative ζ_5 .

2) Unipolar devices: Temperature dependency of turn-off dV_{ds}/dt of Si and SiC MOSFETs is [8]:

$$\left. \frac{dV_{DS}^2}{dt} \right|_{off} = \frac{\alpha_6 \frac{dG_m}{dT} + \beta_6 \frac{dV_{th}}{dT}}{\tau_e^2} \quad (6)$$

Where $\tau_e = C_{DS} + C_{OSS2} + C_{GD}(1 + G_m R_G)$. $\alpha_6 = (C_{DS} + C_{OSS2} + C_{GD})(V_{th} - V_{GG(off)}) - I_L R_G C_{GD}$. $\beta_6 = \tau_e G_m$

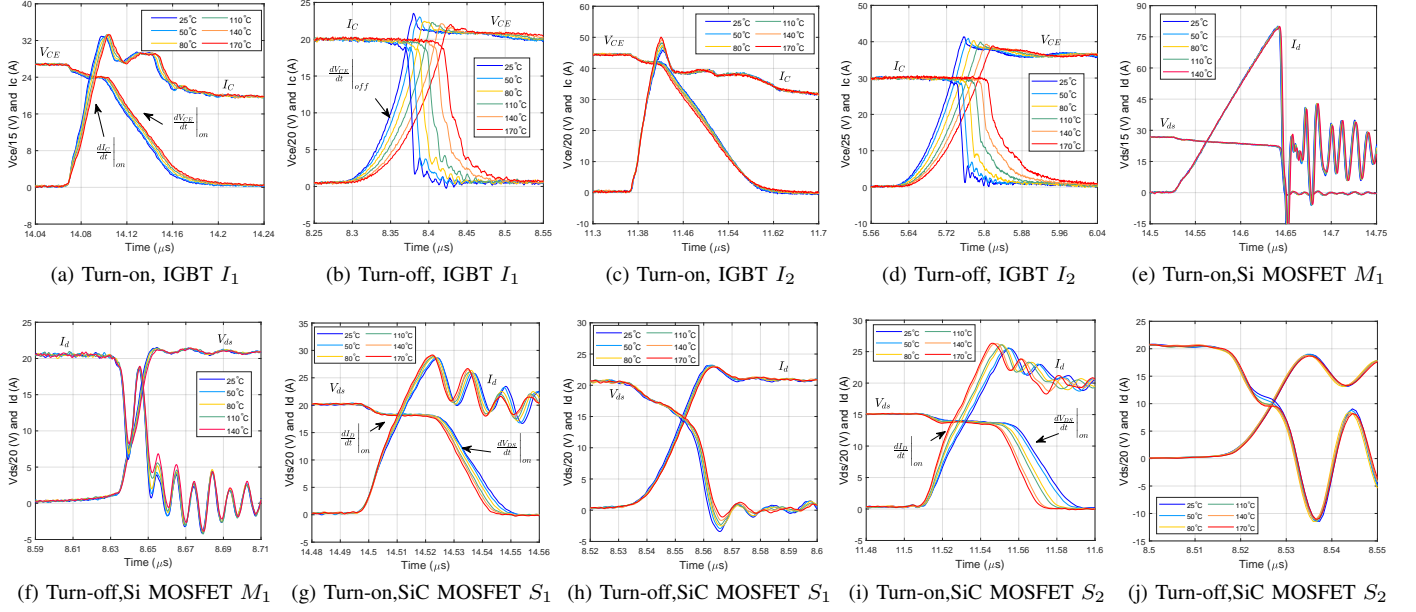


Fig. 3. Comparison of experimental switching waveforms when low-side T_{J1} varies while high-side $T_{J2} = 25^\circ\text{C}$.

Noting that the β_6 is much larger than α_6 in the typical applications. The $dV_{DS}^2/dtdT|_{off}$ is thereby mainly determined by the dV_{th}/dT . For SiC MOSFET and Si MOSFET, their V_{th} have NTCs. Their turn-off $dV_{DS}/dt|_{off}$ thereby also have NTCs due to the positive β_6 .

E. T_{J2} dependency of Turn-on dV/dt

The T_{J2} dependency of Turn-on dV/dt of IGBT, Si and SiC MOSFETs is:

$$\left. \frac{dV^2}{dt} \right|_{on} = - \frac{G_m(V_{GG(on)} - V_{th}) - I_L}{\tau_b^2} \frac{dC_{ext,d}}{dT} \quad (7)$$

$C_{ext,d}$ is the charge extraction capacitance induced by the excess charge dynamics in the N-base of the freewheeling diode, as shown in Fig. 2d. The $C_{ext,d}$ is similar to that of C_{ext} for IGBT. When the junction temperature becomes higher, the excess charge Q_d greatly increases [10], which generates larger $C_{ext,d}$. The $C_{ext,d}$ thereby has a PTC.

III. EXPERIMENTAL INVESTIGATION ON TEMPERATURE DEPENDENCY OF SWITCHING BEHAVIOUR.

A. T_{J1} dependency on switching behaviour of IGBT, Si and SiC MOSFET

1) IGBT: Figs. 3a and c shows the turn-on waveforms of IGBTs I_1 and I_2 when T_{J1} is heated to various temperatures (from 25°C to 170°C) while T_{J2} is kept at 25°C . The $dI_C/dt|_{on}$ has a NTC for I_1 and PTC for I_2 . According to (1), the dV_{th}/dT and dG_m/dT have opposite impacts on the $dI_C^2/dtdT|_{on}$, which give rise to weak T_{J1} dependency of $dI_C/dt|_{on}$.

In Figs. 3a and c, the temperature dependency of the $dV_{CE}/dt|_{on}$ agree with the analysis proposed for (3). In the beginning of V_{CE} falling transient, C_Q is approximately temperature-independent. The $dV_{CE}/dt|_{on}$ has

a weak temperature dependency since the impacts of dV_{th}/dT and dG_m/dT counteract. When V_{CE} drops to tens of volts, C_Q becomes temperature-dependent, which induces an NTC for $dV_{CE}/dt|_{on}$. Fig. 3b and d compares the turn-off waveforms of f IGBTs I_1 and I_2 when T_{J1} varies from 25°C to 170°C while $T_{J2} = 25^\circ\text{C}$. The $dV_{CE}/dt|_{off}$ greatly reduces with the increase of T_{J1} and has a NTC. The strong T_{J1} dependency is due to the temperature-dependent C_{ext} in (5).

Figs. 3b and d show the turn-off waveforms of I_C for IGBTs I_1 and I_2 . In the initial I_C reduction phase, dI/dt slightly decreases with the increase of T_{J1} and has an NTC. In this phase, the current reduction is due to the MOS current turn-off. According to (2), the $dI^2/dtdT|_{off}$ is determined by dV_{th}/dT . Since the V_{th} of IGBT has an NTC, an NTC is thereby obtained for dI/dt in this phase. In Fig. 3b and d, the tail current greatly increases with the increase of T_{J1} . With higher T_{J1} , a higher excess carrier density is obtained, which generates a larger residual excess charge in the N-base to support tail current.

2) Si MOSFET: Fig. 3e compares the turn-on waveforms of Si MOSFET when T_{J1} varies from 25°C to 140°C , while T_{J2} is kept at 25°C . The $dI_D/dt|_{on}$ and $dV_{DS}/dt|_{on}$ of Si MOSFET decreases with when T_{J1} becomes higher and NTCs are obtained. In (1) and (4), the impacts of dV_{th}/dT and dG_m/dT counteract for both $dI^2/dtdT|_{on}$ and $dV_{DS}^2/dtdT|_{on}$. For the Si MOSFET, the dG_m/dT shows stronger impact and a NTC is thereby obtained for $dI_D/dt|_{on}$ and $dV_{DS}/dt|_{on}$. However, the temperature dependency is very weak.

Fig. 3f compares the turn-off waveforms of Si MOSFET when T_{J1} varies from 25°C to 140°C while $T_{J2} = 25^\circ\text{C}$. The $dI_D/dt|_{off}$ and $dV_{DS}/dt|_{off}$ reduces with the increase of T_{J1} and NTCs is obtained. Since $dI^2/dtdT|_{off}$ and

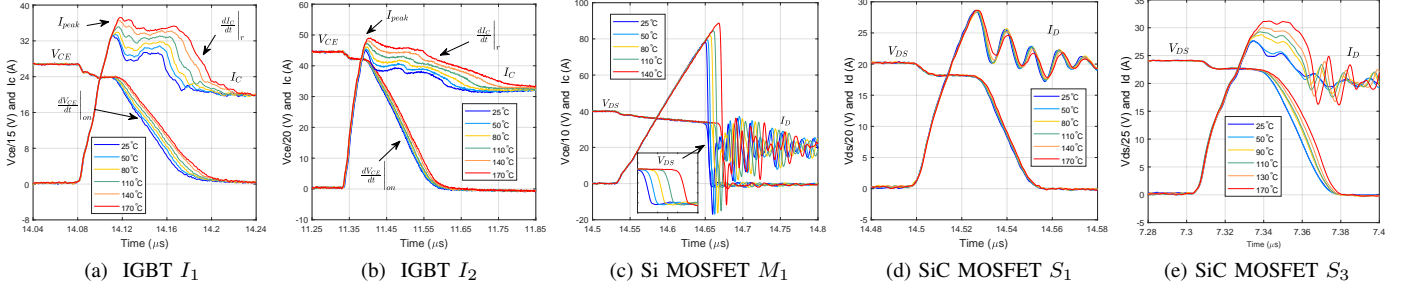


Fig. 4. Comparison of experimental turn-on waveforms when high-side T_{J2} varies while low-side $T_{J1} = 25^\circ\text{C}$.

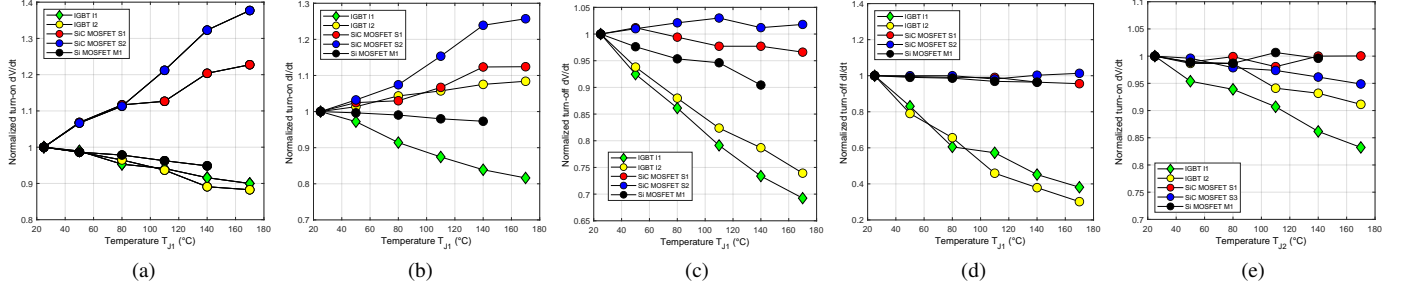


Fig. 5. Normalized dV/dt and dI/dt of IGBT, Si MOSFET and SiC MOSFET. (a) Normalized turn-on dV/dt , (b) Normalized turn-on dI/dt , (c) Normalized turn-off dV/dt , (d) Normalized turn-off dI/dt when T_{J1} varies while $T_{J2} = 25^\circ\text{C}$. (e) Normalized turn-on dV/dt when T_{J2} varies while $T_{J1} = 25^\circ\text{C}$.

$dV_{DS}^2/dtdT|_{off}$ are mainly determined by dV_{th}/dT , NTCs are thereby achieved for $dI_D/dt|_{off}$ and $dV_{DS}/dt|_{off}$.

3) SiC MOSFET: Figs. 3g and i compare the turn-on waveforms of SiC MOSFETs S_1 and S_2 when T_{J1} varies from 25°C to 170°C , while T_{J2} is kept at 25°C . Unlike the other devices, the $dI_D/dt|_{on}$ and $dV_{DS}/dt|_{on}$ of the SiC MOSFET increases when T_{J1} becomes higher. The PTCs of $dI_D/dt|_{on}$ and $dV_{DS}/dt|_{on}$ are due to the PTC of G_m . As shown in (1) and (4), with a PTC for G_m , the impact of dV_{th}/dT and dG_m/dT can add up. $dI_D/dt|_{on}$ and $dV_{DS}/dt|_{on}$ thereby have PTCs.

Figs. 3h and j compare the turn-off waveforms of SiC MOSFETs S_1 and S_2 when T_{J1} varies from 25°C to 170°C while $T_{J2} = 25^\circ\text{C}$. With the increase of T_{J1} , $dI_D/dt|_{off}$ and $dV_{DS}/dt|_{off}$ reduces and have NTCs. As shown in (2) and (6), the $dV_{DS}^2/dtdT|_{off}$ and $dI^2/dtdT|_{off}$ of unipolar devices can be mainly determined by the dV_{th}/dT . Since V_{th} of S_1 has a NTC, $dI_D/dt|_{off}$ and $dV_{DS}/dt|_{off}$ for S_1 has a NTC, as shown in Fig. 3h. In (2) and (6), the impact of dV_{th}/dT and dG_m/dT can also contract with each other and $dI_D/dt|_{off}$ and $dV_{DS}/dt|_{off}$ of S_2 becomes temperature independent.

B. T_{J2} dependency on switching behaviour of IGBT, Si and SiC MOSFET

1) IGBT: Figs. 4a and b show the experimental turn-on waveforms of IGBTs I_1 and I_2 using various T_{J2} . With higher T_{J2} , the excess charge of p-i-n diode increases, which supports a higher peak current I_{peak} , softer reverse recovery and larger charge extraction capacitance C_{ext-d} . The I_{peak} thereby has a PTC whereas the $dV_{CE}/dt|_{on}$ have NTCs. In Figs. 4a and b, the snap-back current slope $dI/dt|_r$ also have NTC. This is

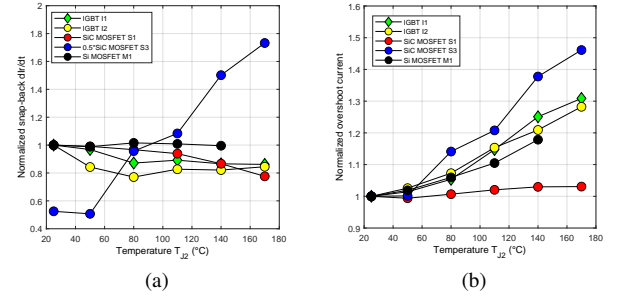


Fig. 6. Normalized (a) dI_r/dt and (b) overshoot current I_o of IGBT, Si MOSFET and SiC MOSFET when T_{J2} varies while $T_{J1} = 25^\circ\text{C}$.

because the higher temperature induced larger excess charge, which support softer reverse recovery.

2) Si MOSFET: Fig. 4c shows the turn-on waveforms of Si MOSFET M_1 utilizing various T_{J2} . With the increase of T_{J2} , a higher excess charge is used to support a larger I_{peak} . The I_{peak} thereby has PTC. In Fig. 4c, it can be noticed that the I_{peak} of Si MOSFET is very large. The large I_{peak} is due to the two-dimensional depletion behavior of superjunction, which exhausted the N-base excess charge to generates the large I_{peak} [11]. Since a very small amount of residual charge is left to support reverse recovery, high snap-back current slope $dI/dt|_r$ is generated [12]. Since the residual charge is negligible, the $dV_{DS}/dt|_{on}$ and $dI/dt|_r$ at turn-on are approximately temperature-independent.

3) SiC MOSFET: Figs. 4d and e shows the turn-on waveforms of SiC MOSFETs S_1 and S_3 using various T_{J2} . The peak current I_{peak} increase with the increase of T_{J2} and has PTC. The $dV_{DS}/dt|_{on}$ has a NTC and decreases when T_{J2}

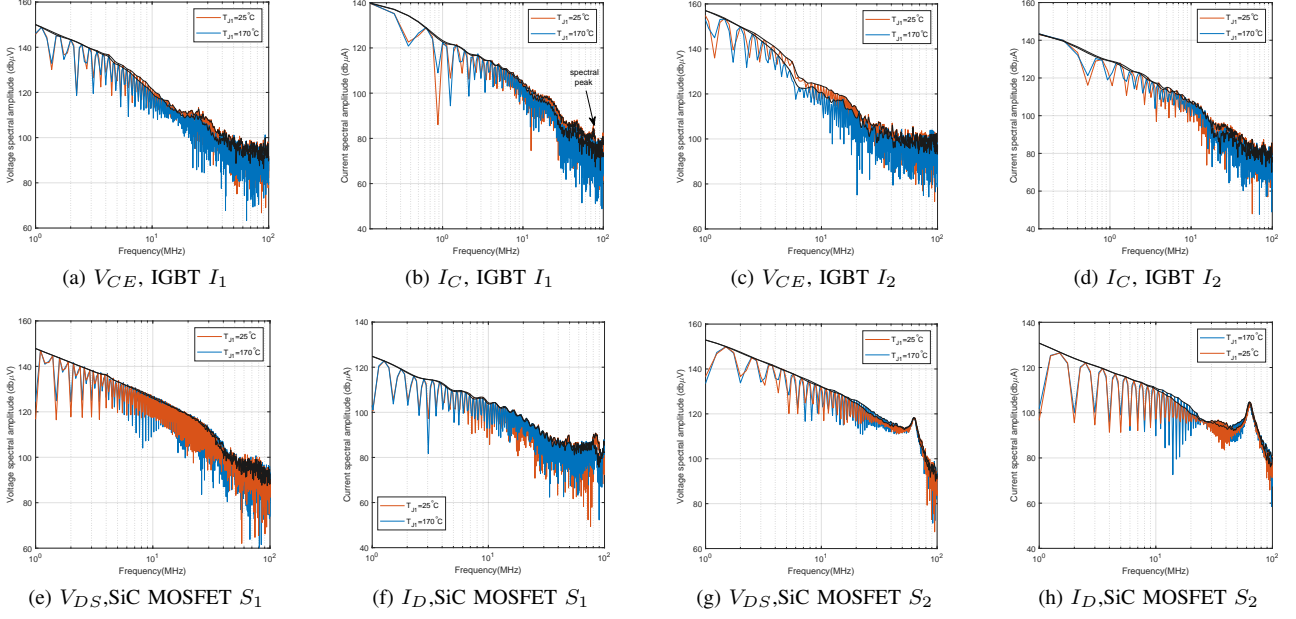


Fig. 7. Computed spectral amplitude of various devices when T_{J1} is 25°C and 170°C while $T_{J2} = 25^\circ\text{C}$.

is higher. The $dI/dt|_r$ have NTC for S_1 and PTC for S_2 .

IV. COMPARISON ON T_{J1} AND T_{J2} DEPENDENCY OF NORMALIZED dV/dt AND dI/dt

Figs. 5a-d compare the T_{J1} dependent dV/dt and dI/dt for IGBTs, Si MOSFETs, SiC MOSFETs. In Figs. 5e and 6, the T_{J2} dependent turn-on dV/dt , overshoot current I_{os} ($I_{os} = I_{peak} - I_L$) and $dI/dt|_r$ of IGBTs, Si MOSFETs, SiC MOSFETs are compared. Their values are extracted and normalized to their corresponding value at 25°C.

As shown in Figs. 5a and b, The SiC MOSFET S_1 and S_2 has large PTCs on turn-on dV/dt and dI/dt . When T_{J1} increases from 25°C to 170°C, its turn-on dV/dt can increase up to 38% and turn-on dI/dt can increase up to 27%. The turn-on dV/dt of IGBTs has a relatively strong NTCs due to the temperature dependent C_Q . The turn-on dV/dt and dI/dt of Si MOSFET M_1 is the weakest.

As shown in Figs. 5c and d, the turn-off dV/dt and dI/dt of Si IGBT I_1 and I_2 shows the strongest T_{J1} dependency. This is because the turn-off behaviour of Si IGBT is greatly affected by the excess charge dynamic in the N-base. Due to the temperature dependent excess carrier density, the $dV_{CE}/dt|_{off}$ of IGBT shows strong T_{J1} dependency. Due to the unipolar nature, Si MOSFET and SiC MOSFET shows much weaker T_{J1} dependency on turn-off dV/dt and dI/dt .

As shown in Figs. 5e and 6, the IGBTs I_1 and I_2 and 1200V rated SiC MOSFET S_3 show strong T_{J2} dependency for turn-on dV/dt , I_{os} and $dI/dt|_r$. The S_3 also has the strongest PTC of I_{os} and $dI/dt|_r$. This is due to the temperature-dependent excess charge in the N-base of the p-i-n diode. Moreover, the increase charge of S_3 is not able to support high I_{os} , which induces the large PTC of $dI/dt|_r$.

Due to the highly doped N-base, the 650V rated SiC MOSFET S_3 has a unipolar body diode and the T_{J2}

dependency is very weak. With two-dimensional depletion behavior, the M_1 has strong T_{J2} dependency on I_{os} , while its turn-on dV/dt and $dI/dt|_r$ are temperature independent.

V. TEMPERATURE DEPENDENCY ON EMI GENERATION

The switching waveforms of V_{CE} and I_C for IGBT are T_{J1} dependent. For SiC MOSFET, the T_{J1} has a significant impact on V_{DS} and I_D waveforms at turn-on transient. Following the approach presented in [5], [13], FFT is performed on the trapezoidal switching waveforms of IGBTs and SiC MOSFETs and Si MOSFET, which show strong temperature dependency.

A. T_{J1} dependent EMI of IGBT and SiC MOSFET

Figs. 7a-d show the FFT computed spectral amplitudes of V_{CE} and I_C when T_{J1} is 25°C and 170°C while $T_{J2} = 25^\circ\text{C}$ for IGBTs I_1 and I_2 . The spectral envelopes are plotted in black lines. The V_{CE} spectral amplitude at $T_{J1} = 170^\circ\text{C}$ reduces 2-5 dB within 4-80 MHz compared to that at $T_{J1} = 25^\circ\text{C}$ due to the NTC $dV_{CE}/dt|_{off}$.

The I_C spectral amplitude at $T_{J1} = 170^\circ\text{C}$ reduces 1-4 dB within 10-80 MHz compared to that at $T_{J1} = 25^\circ\text{C}$. With higher T_{J1} , the $dI_C/dt|_{off}$ of IGBT greatly decreases, which gives rise to the reduction of I_C spectral amplitude.

Figs. 7e-h show the FFT computed V_{DS} and I_D spectral amplitude for SiC MOSFETs S_1 and S_2 when T_{J1} is 25°C and 170°C while $T_{J2} = 25^\circ\text{C}$. Since the turn-on dV/dt of SiC MOSFET has a PTC, V_{DS} spectral amplitude within 10-40 MHz increases 1-3 dB when T_{J1} varies from 25°C to 170°C. Due to the PTC of turn-on dI/dt for SiC MOSFET, the I_D spectral amplitude at $T_{J1} = 170^\circ\text{C}$ increases about 1-3 dB compared to that at $T_{J1} = 25^\circ\text{C}$.

B. T_{J2} dependent EMI of IGBT, Si and SiC MOSFET

Figs. 8a show the FFT computed V_{CE} spectral amplitude of IGBT I_1 when T_{J2} is 25°C and 170°C while $T_{J1} = 25^\circ\text{C}$. The

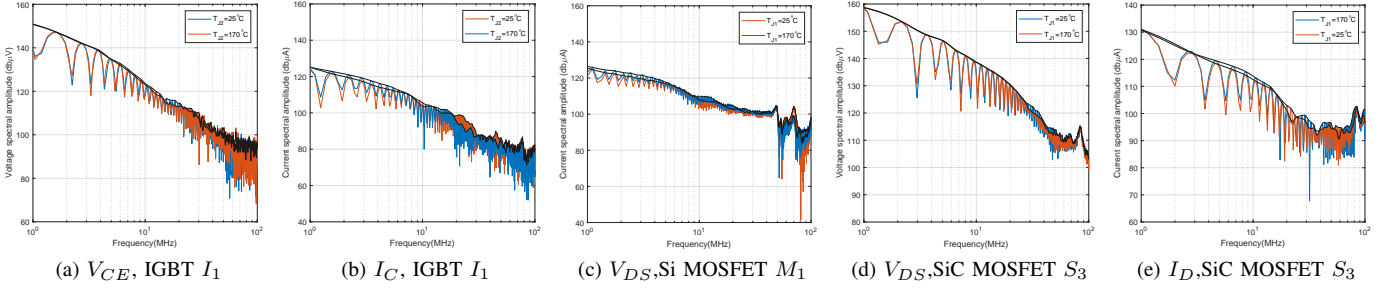


Fig. 8. Computed spectral amplitude when T_{J2} is 25°C and 170°C while $T_{J1} = 25^\circ\text{C}$.

spectral envelopes are plotted in black lines. Due to the NTC of turn-on dV/dt , the spectral amplitude of V_{CE} at $T_{J2} = 170^\circ\text{C}$ within 14-20 MHz reduces 2-3 dB compared to that at $T_{J2} = 25^\circ\text{C}$, as shown in Fig. 8a. Fig. 8b shows the FFT computed I_C spectral amplitude of IGBT I_1 when T_{J2} is 25°C and 170°C while $T_{J1} = 25^\circ\text{C}$. Since the I_{os} of IGBT has a PTC while $dI/dt|_r$ has a NTC. Due to the PTC of I_{os} , the spectral amplitude of I_C at $T_{J2} = 170^\circ\text{C}$ is 1-3 dB higher than that at $T_{J2} = 25^\circ\text{C}$ within 12-20 MHz. Due to the NTC of $dI/dt|_r$, the I_C spectral amplitude at $T_{J2} = 170^\circ\text{C}$ reduces 1-6 dB within 20 - 50 MHz compared to that at $T_{J2} = 25^\circ\text{C}$.

Fig. 8c shows the I_D spectral amplitude of Si MOSFET M_1 when T_{J2} is 25°C and 140°C while $T_{J1} = 25^\circ\text{C}$. Due to the PTC of I_{os} for Si MOSFET, the spectral amplitude of I_D at $T_{J2} = 140^\circ\text{C}$ is 1-3 dB higher than that at $T_{J2} = 25^\circ\text{C}$ within 1-40 MHz. Figs. 8 d-e show the I_D and V_{DS} spectral amplitude of SiC MOSFET S_3 when T_{J2} is 25°C and 170°C while $T_{J1} = 25^\circ\text{C}$. Due to the NTC of turn-on dV/dt , the spectral amplitude of V_{DS} at $T_{J1} = 170^\circ\text{C}$ becomes 1-4 dB lower than that at $T_{J1} = 25^\circ\text{C}$ between 30-50 MHz. Due to the PTC of I_{os} and the high peak current induced snappy current overshoot, the spectral amplitude of I_D at $T_{J1} = 170^\circ\text{C}$ becomes 1-5 dB higher than that at 25°C between 15-90 MHz.

VI. CONCLUSION

This paper compares the impact of low-side T_{J1} and high-side T_{J2} on dV/dt and dI/dt and EMI generation for IGBTs, Si MOSFETs, and SiC MOSFETs. Due to the temperature dependency of excess charge dynamics in the N-base, the turn-on dV/dt , turn-off dI/dt and turn-off dV/dt of IGBT are strongly dependent on T_{J1} and have NTCs. Due to the NTC of G_m , the turn-on dI/dt of IGBT also has NTC, and its T_{J1} dependency is relatively strong. The current and voltage spectral amplitude of IGBT thereby reduce when T_{J1} increases. Since SiC MOSFET has a PTC for G_m , its temperature-dependent effects of G_m and V_{th} can add up at turn-on transient. This induces large PTCs of turn-on dI/dt and turn-on dV/dt , which generate the T_{J1} dependency of the current and voltage spectral amplitude for SiC MOSFET. The dV/dt and dI/dt of Si MOSFET have a weak T_{J1} dependency. In the end, the temperature-dependent EMI generation for IGBTs, Si MOSFETs and SiC MOSFETs are also clarified.

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